



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

July 11, 2026

IGI Report Number

LG817652541

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

OVAL BRILLIANT

Measurements

12.25 X 8.20 X 5.07 MM

GRADING RESULTS

Carat Weight

3.19 CARATS

Color Grade

D

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

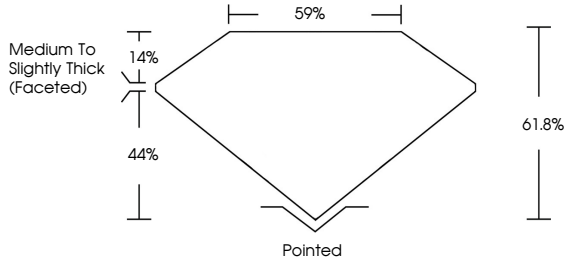
NONE

Inscription(s)

 LG817652541

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Medium To Slightly Thick (Faceted)



Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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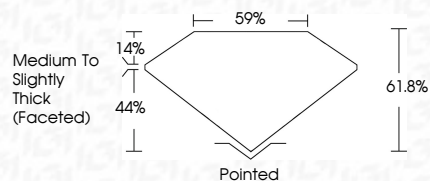
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July 11, 2026

IGI Report No LG817652541

OVAL BRILLIANT

12.25 X 8.20 X 5.07 MM

3.19 CARATS

D

VVS 2

D

61.8%

59%

Medium To Slightly Thick (Faceted)

Pointed

EXCELLENT

EXCELLENT

NONE

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www.igi.org